



JPW

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Sadayoshi HORII et al.

Group Art Unit: 1763

Application No.: 10/529,466

Examiner: R. BUEKER

Filed: March 29, 2005

Docket No.: 123373

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE AND SUBSTRATE  
PROCESSING APPARATUS

**SUPPLEMENTAL AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

As a supplement to the Amendment filed on July 17, 2007, please further consider the  
following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**